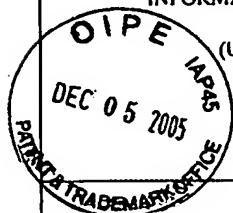


Form PTO-1449
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118319APPLICATION NO.
10/765,200

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

APPLICANT
Mutsumi KIMURAFILING DATE
January 28, 2004GROUP
2818

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
PD	1.	JP A 11-282995 w/Abstract and Translation	10/15/1999	Japan		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

PD	2.	S. Utsunomiya et al., "Low Temperature Poly-Si TFT-LCD Transferred onto Plastic Substrate Using Surface Free Technology by Laser Ablation/Annealing (SUFTLA [®]), Asia Display/IDW '01, pages 339-342

EXAMINER

PHUC T. DANG

DATE CONSIDERED

3/8/06

Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.